

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT APPLICATION of: Confirmation Number: 7394
FUKIAGE et al.

Application No.: 10/702,048 Group Art Unit: 1792

Filed: November 6, 2003 Examiner: Tadayyon Eslami, Tabassom

Title: Method for Depositing Materials on a Substrate

AMENDMENT AFTER FINAL REJECTION

Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Sir:

In response to the Final Office Action dated October 1, 2008, the due date for the response being January 1, 2009, please amend the above-identified application as follows: